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APPLICANTS

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\*\* CONTINUING DATA ..... *MK (Verified)*

This application is a CON of 09/764,523 01/18/2001 PAT 6,736,147  
 which claims benefit of 60/176,592 01/18/2000

\*\* FOREIGN APPLICATIONS ..... *MK (NONE)*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED  
 \*\* 04/21/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWING 5	TOTAL CLAIMS 22	INDEPENDENT CLAIMS 3
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Verified and Acknowledged  
 Examiner's Signature *info* Initials *MK*

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 20995  
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TITLE  
 Semiconductor processing with a remote plasma source for self-cleaning

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )
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